



Do NOT enter. /K.T.C./

Atty. Dkt. No. 039262-0154

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tadahiro OHMI et al.
Title: PLASMA PROCESSING APPARATUS
Appl. No.: 10/584,137
Filing Date: 8/1/06
Examiner: Keath T. Chen
Art Unit: 1792
Confirmation No.: 4094

AMENDMENT AND REPLY UNDER 37 CFR 1.116

Mail Stop **BOX AF**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Final Office Action dated November 5, 2008, concerning the above-referenced patent application.

Applicants have submitted herewith a petition and fee for a three-month extension of time, to make this response timely.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows:

05/04/2009 MAHMEI 00000014 10504137

02 FC:2253

555.00 0P